



Docket No. 1514.1033

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Serial No. 10/694,030

Group Art Unit: 2815

Confirmation No. 3879

Filed: October 28, 2003

Examiner: Matthew C. Landau

For: POLYCRYSTALLINE SILICON THIN FILM, FABRICATION METHOD THEREOF, AND THIN FILM TRANSISTOR WITHOUT DIRECTIONAL DEPENDENCY ON ACTIVE CHANNELS FABRICATED USING THE SAME

SUPPLEMENTAL AMENDMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Supplemental Amendment and the accompanying Request for Continued Examination are in response to the Advisory Action mailed February 8, 2006. Please enter the Amendment After Final Rejection filed on January 26, 2006, which the Examiner refused to enter in the Advisory Action of February 8, 2006.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of the claims that begins on page 3 of this paper.

Remarks begin on page 6 of this paper.